Charge Collection and Trapping in Epitaxial Silicon Detectors after Neutron-Irradiation

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In the framework of the CERN RD50 Collaboration

Outline

- Introduction
- Transient Current Technique (TCT)
- Determination of field dependent trapping time $\boldsymbol{\tau}$
 - Simulation of TCT signal
 - Electric field and space charge distribution
 - Field dependent τ
 - Fit of the Charge Collection Efficiency (CCE)
- Fluence Dependence of $1/\tau$
- Summary and Conclusion

Introduction

Trapping

- Most limiting factor for S-LHC
- Charge Collection Efficiency (CCE) decreases

Aim of this work

- Determination of trapping time τ
- taking into account double peak distortions to the electric field
- Investigation of field dependence of τ

Introduction

Why field dependent?

τ = constant

- often used for $\phi < 2 \cdot 10^{14} \text{ cm}^{-2}$ (FZ, MCz)
- not suitable for $\phi > 10^{15} \text{ cm}^{-2}$

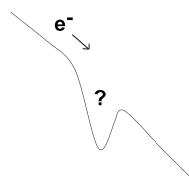
τ voltage dependent

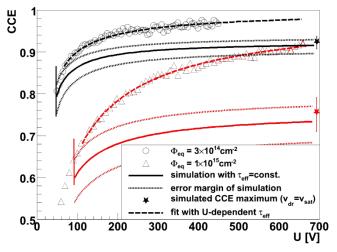
empirical model, good description for $\phi > 10^{15} \text{ cm}^{-2}$ possible

τ field dependent

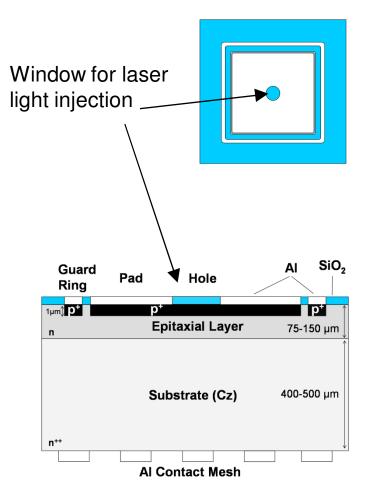
motivated by:

- field dependent trapping cross section $\sigma(E)$?
- field enhanced detrapping ?
- trap filling ?





Investigated Samples



Samples and irradiation

n-type epitaxial silicon pad detectors

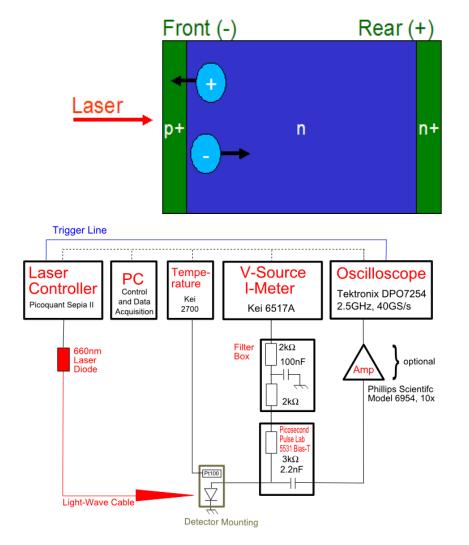
- thickness d: 150 μm
- area: 2.5 x 2.5 mm²
- neutron fluence ϕ : 1·10¹⁵ to 4·10¹⁵ cm⁻²
 - \Rightarrow type inversion
 - \Rightarrow probably below charge multiplication range

Why epitaxial detectors?

- thin layer can be grown (device engineering)
- high oxygen concentration (good radiation hardness)
 All properties can be tuned
- \Rightarrow Optimization of radiation hardness possible

Transient Current Technique (TCT)

- Front side injection (p+ side)
- 660 nm / 670 nm laser light (penetration depth 3 μm)
 ⇒ electron signal
- Short laser pulse – FWHM 70 ps
- Small pad diodes
 - d = 150 μm, C = 4.3 pF
 2.5 GHz Oscilloscope
 - measured rise time = 600 ps

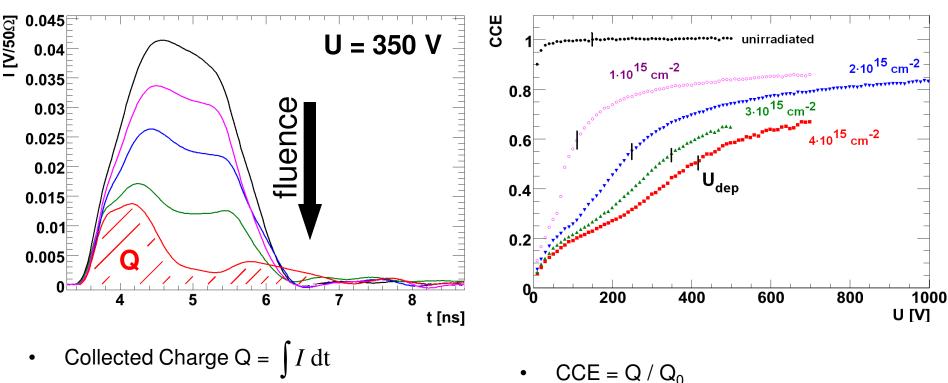


Determination of Charge Collection Efficiency from TCT Measurements

TCT signal

Charge Collection Efficiency (CCE)

Unirradiated diodes: CCE = 1



- Deposited Charge $Q_0 = \int I_{\text{non irradiated}} dt$
- Trapping reduces collected charge Q.

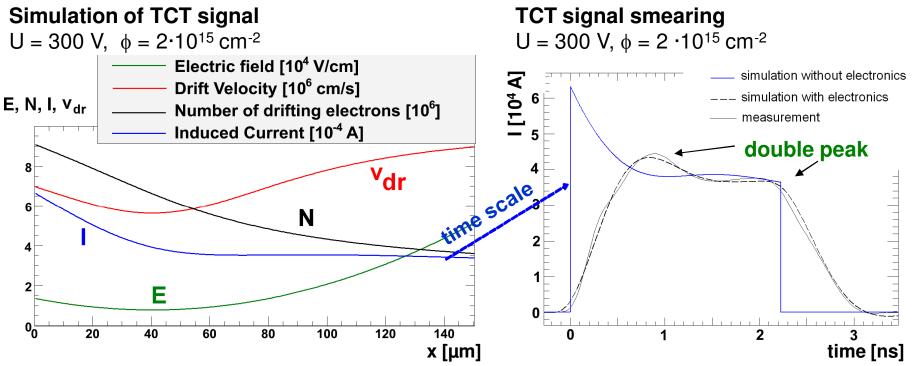
Determination of $\tau(E)$

Initial guess of field distribution (i.g. linear, parabolic)

- Assumption of electric field parameters
- Fit of CCE curves by simulation with parameter τ
- Agreement of measured and simulated TCT signal? Yes / No

modification of E(x)

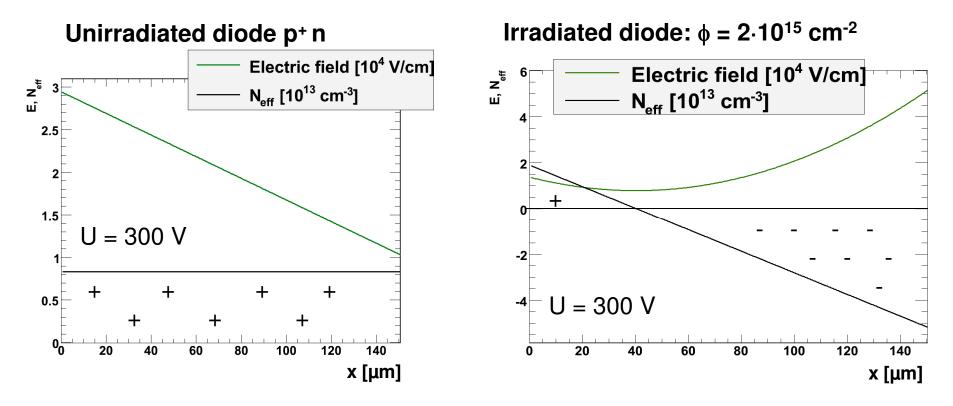
Simulation of TCT Signal



Simulation takes into account:

- Number of drifting electrons N reduces while drifting (trapping)
- Parabolic E-field needed to describe double peak (space charge distribution)
- Saturation of drift velocity $v_{dr}(E(x))$
- Induced current $I(t) = v_{dr} \cdot N \cdot e_0 / d$ (Ramo's Theorem)
- Electronic circuit effects (calculated with SPICE)

Electric Field and Space Charge Distribution N_{eff}



homogenous space charge distribution => linear electric field

 \Rightarrow double peak not described

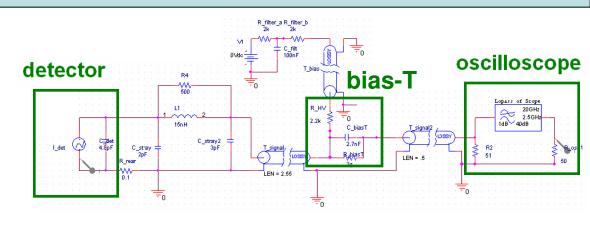
linear space charge distribution => parabolic electric field

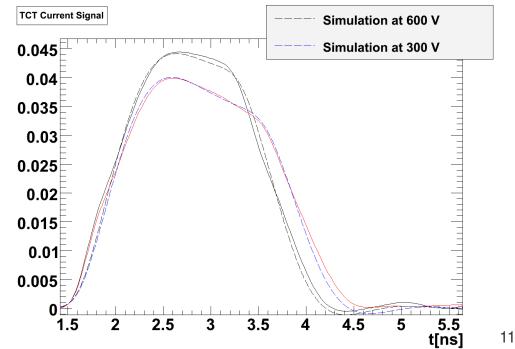
 \Rightarrow good agreement between simulated and measured TCT signal possible

Circuit Simulation

Circuit simulation

- Calculated with SPICE
- Unirradiated diodes used for calibration





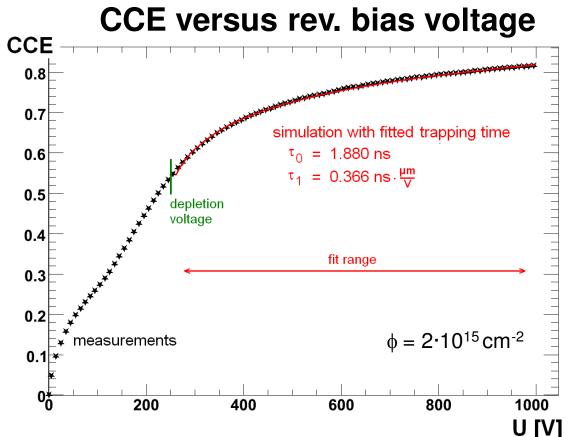
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Fit of the CCE curve

Trapping model: $-dN = \frac{1}{\tau (E(x(t)))}$ N dt

Parameterisation of τ : $\tau = \tau_0 + \tau_1 E$

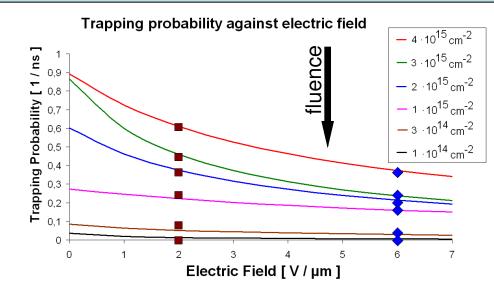
- fit simulated CCE curve to the measured CCE values
- free parameters: τ_0 , τ_1



Field Dependence and Fluence Dependence of $1/\tau$

Trapping probability $1/\tau$ decreases with increasing electric field E

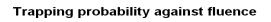
$$\frac{1}{\tau} = \frac{1}{\tau_0 + \tau_1 \cdot \mathbf{E}}$$

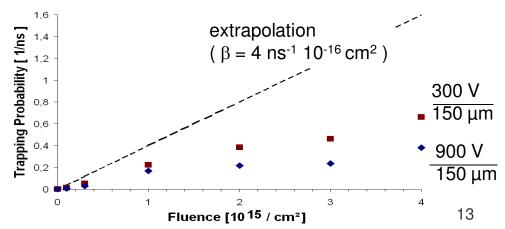


Previous investigations (by G.

Kramberger):

- Method: Charge Correction (CCM)
- up to fluences of 2.1014 cm-2
- τ = const
- 1/ $\tau = \beta \ \varphi$





Summary and Conclusion

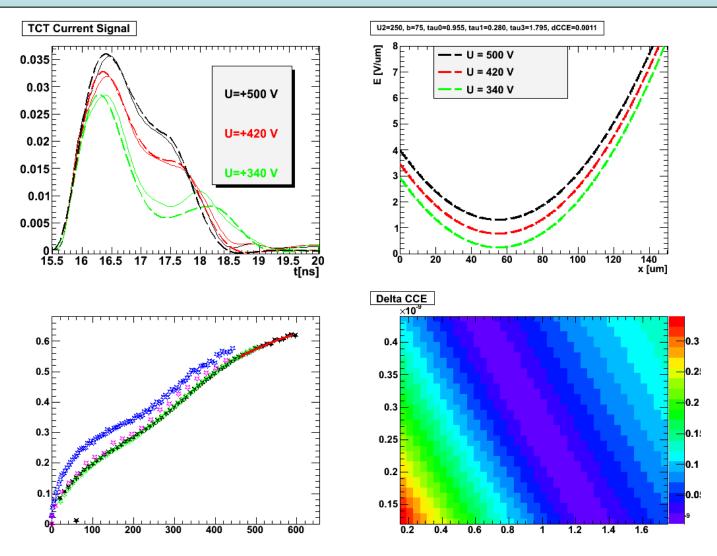
Charge collection and trapping can be well described taking into account

- distortions to the space charge distribution leading to parabolic electric fields (double peak)
- field-dependence of trapping time τ (to fit CCE curves)
- electronic circuit effects (to simulate TCT signals)

Trapping probability decreases with increasing E-field \Rightarrow high E-fields desirable to reduce trapping probability

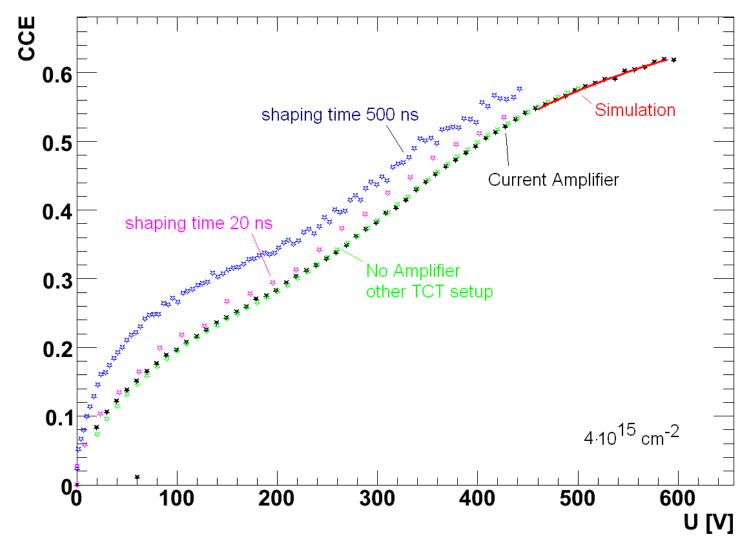
Backup Slides

Overview of E(x), I(t) and CCE(U) for a 4.10¹⁵ DO

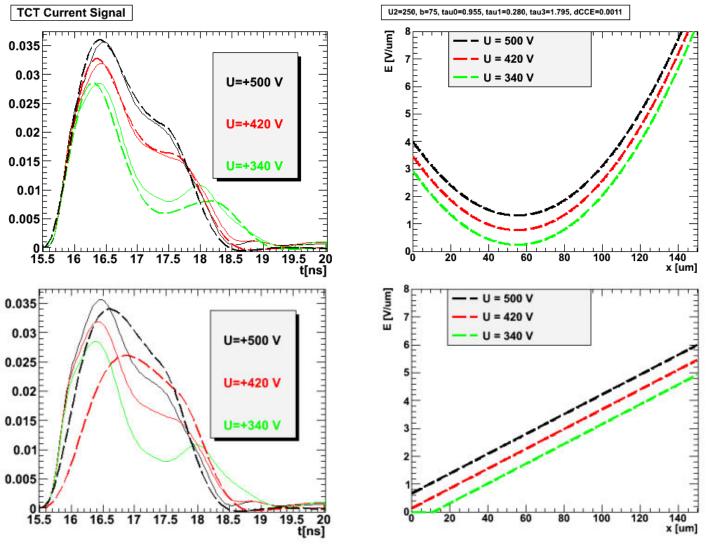


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CCE-curves measured with different setups

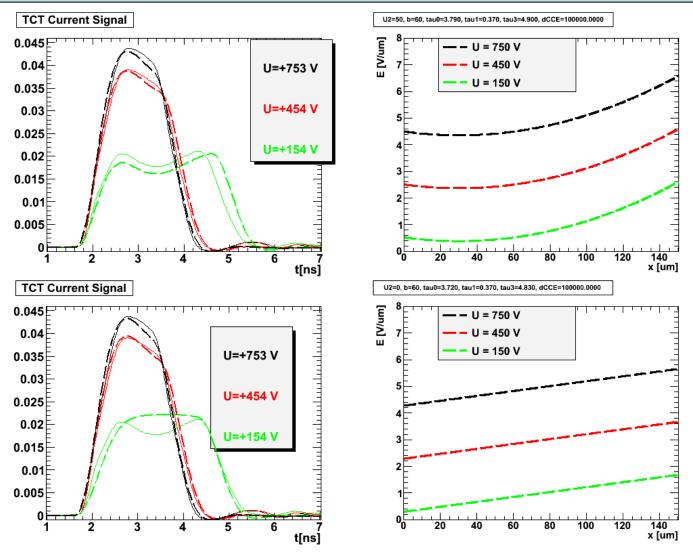


Parabolic and Linear Electric Field for 4.10¹⁵ cm⁻² DO



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Parabolic and Linear Electric Field for 1.10¹⁵ cm⁻² DO



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Drift Velocity

$$v_{dr} = \frac{\mu_0 E}{\left(1 + \left(\frac{\mu_0 E}{v_{sat}}\right)^{\beta}\right)^{1/\beta}}$$

$$v_{sat} = 9.814 \cdot 10^4 \text{ m/s}$$

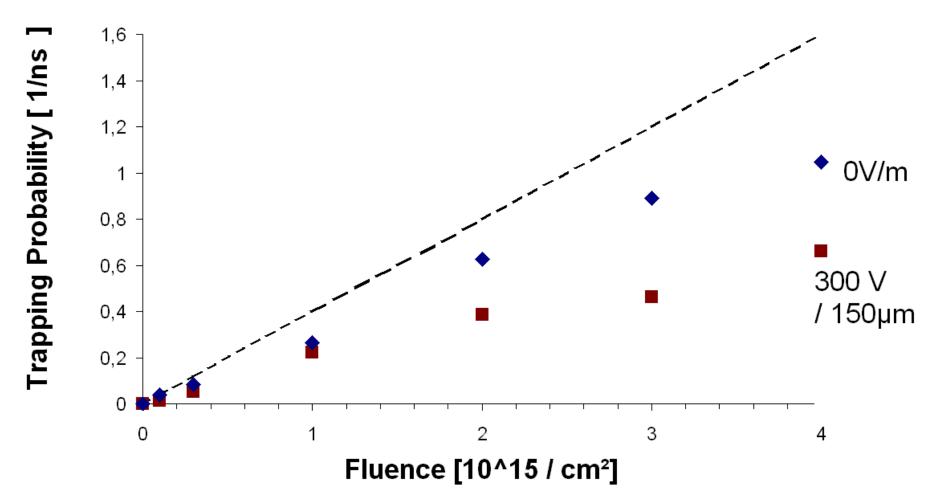
$$\mu_0 = 0.1447 \text{ m}^2/\text{Vs}$$

$$\beta = 1.1073$$

(modified Jacoboni at 294 K)

TCT Signal of Unirradiated Diode

Trapping probability against fluence



Comparison of Different Models for E(x) and τ

